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DATE MAILED: 06/03/2005

APPLICATION NO	).	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/665,524	10/665,524 09/22/2003		Hideomi Koinuma	32307-191598 5810	
26694	7590	06/03/2005		EXAMINER	
VENABL	E LLP			MANDALA, VICTOR A	
P.O. BOX					DA DED MUMBED
WASHINGTON, DC 20045-9998				ART UNIT	PAPER NUMBER
				2826	

Please find below and/or attached an Office communication concerning this application or proceeding.

EK

	Application No.	Applicant(s)					
	10/665,524	KOINUMA ET AL.					
Office Action Summary	Examiner	Art Unit					
	Victor A. Mandala Jr.	2826					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply sistent above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).  Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).							
Status							
1) Responsive to communication(s) filed on 18 Ag	<u>oril 2005</u> .	•					
2a)☐ This action is <b>FINAL</b> . 2b)☒ This	action is non-final.						
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closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	63 O.G. 213.					
Disposition of Claims							
4) □ Claim(s) 1-76 is/are pending in the application. 4a) Of the above claim(s) 2-76 is/are withdrawn 5) □ Claim(s) is/are allowed. 6) □ Claim(s) 1 is/are rejected. 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restriction and/or	from consideration.						
Application Papers							
<ul> <li>9) The specification is objected to by the Examine</li> <li>10) The drawing(s) filed on is/are: a) access applicant may not request that any objection to the objected travel</li> <li>11) The oath or declaration is objected to by the Examine</li> </ul>	epted or b) objected to by the Edrawing(s) be held in abeyance. See ion is required if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 CFR 1.121(d).					
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) All b) Some * c) None of:  1. Certified copies of the priority documents have been received.  2. Certified copies of the priority documents have been received in Application No  3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  * See the attached detailed Office action for a list of the certified copies not received.							
Attachment(s)							
Notice of References Cited (PTO-892)  Notice of Draftsperson's Patent Drawing Review (PTO-948)  Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  Paper No(s)/Mail Date 4/30/04, 6/23/04.	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:						

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#### **DETAILED ACTION**

## Election/Restrictions

Claims 2-76 have been withdrawn from further consideration pursuant to 37 CFR 1.142(b) as being drawn to a nonelected Species, there being no allowable generic or linking claim. Election was made without traverse in the reply filed on 4/18/05.

#### **Double Patenting**

The nonstatutory double patenting rejection is based on a judicially created doctrine grounded in public policy (a policy reflected in the statute) so as to prevent the unjustified or improper timewise extension of the "right to exclude" granted by a patent and to prevent possible harassment by multiple assignees. See *In re Goodman*, 11 F.3d 1046, 29 USPQ2d 2010 (Fed. Cir. 1993); *In re Longi*, 759 F.2d 887, 225 USPQ 645 (Fed. Cir. 1985); *In re Van Ornum*, 686 F.2d 937, 214 USPQ 761 (CCPA 1982); *In re Vogel*, 422 F.2d 438, 164 USPQ 619 (CCPA 1970); and, *In re Thorington*, 418 F.2d 528, 163 USPQ 644 (CCPA 1969).

A timely filed terminal disclaimer in compliance with 37 CFR 1.321(c) may be used to overcome an actual or provisional rejection based on a nonstatutory double patenting ground provided the conflicting application or patent is shown to be commonly owned with this application. See 37 CFR 1.130(b).

Effective January 1, 1994, a registered attorney or agent of record may sign a terminal disclaimer. A terminal disclaimer signed by the assignee must fully comply with 37 CFR 3.73(b).

2. Claim 1 is rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claim 1 of U.S. Patent No. 6,888,156

Chikyow et al. Although the conflicting claims are not identical, they are not patentably distinct from each other because the Patent Application claim is broader then U.S. Patent

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No. 6,888,156 claim1, but can still be read on. The Patented claim also teaches an epitaxial layer, where the Application teaches a layer epitaxially grown, which is materially the same layer. The Patented claim teaches a zinc sulfide, where the Application's claim teaches a metal sulfide, which again is materially the same.

## Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claim 1 is rejected under 35 U.S.C. 102(e) as being anticipated by U.S. Patent No. 6,888,156 Chikyow et al.

The applied reference has a common inventor with the instant application. Based upon the earlier effective U.S. filing date of the reference, it constitutes prior art under 35 U.S.C. 102(e). This rejection under 35 U.S.C. 102(e) might be overcome either by a showing under 37 CFR 1.132 that any invention disclosed but not claimed in the reference was derived from the inventor of this application and is thus not the invention "by another," or by an appropriate showing under 37 CFR 1.131.

Referring to claim 1, a thin film device comprising: a metal sulfide layer, (Figure 14 #22), formed on a single crystal silicon substrate, (Figure 14 #21), by epitaxial growth; and a compound thin film, (Figure 14 #23), with ionic bonding, which is formed on the metal sulfide layer, (Figure 14 #22), by epitaxial growth.

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# Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (f) he did not himself invent the subject matter sought to be patented.
- 4. Claim1 is rejected under 35 U.S.C. 102(f) because the applicant did not invent the claimed subject matter. This list of inventors are not in the Application or in U.S. Patent No. 6,888,156 Chikyow et al.:
  - A) Ahmet, Parhat
  - B) Song, Jeong-Hwan
  - C) Kawasaki, Masashi
  - D) Chikyow, Toyohiro
  - E) Chikyo, Toyohiro.

The last two names the examiner is not sure if they are the same person and it is just a misspelling or not.

# Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(a) the invention was known or used by others in this country, or patented or described in a printed publication in this or a foreign country, before the invention thereof by the applicant for a patent.

Claim 1 is rejected under 35 U.S.C. 102(a) as being anticipated by European Patent No. 1271626 Kawasaki et al.

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5. Referring to claim 1, a thin film device comprising: a metal sulfide layer, (Figure 1 #2), formed on a single crystal silicon substrate, (Figure 1 #1), by epitaxial growth; and a compound thin film, (Figure 1 #3), with ionic bonding, which is formed on the metal sulfide, (Figure 1 #2), layer by epitaxial growth.

# Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claim 1 is rejected under 35 U.S.C. 102(b) as being anticipated by Japanese Patent No. 362181483 Muroki.

6. Referring to claim 1, a thin film device comprising, (Derwent Abstract Translation): a metal sulfide layer, (Figure 1 #2 Constitution page 2 lines 6-8), formed on a single crystal silicon substrate, (Figure 1 #1 Constitution page 1 lines 4-5), by epitaxial growth; and a compound thin film with ionic bonding, (Figure 1 #5 Constitution page 2 line 8), which is formed on the metal sulfide, (Figure 1 #2), layer by epitaxial growth.

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#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Victor A. Mandala Jr. whose telephone number is (571)

272-1918. The examiner can normally be reached on Monday through Thursday from NATHAN J. FLYNN SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan J. Flynn can be reached on (571) 272-1915. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

VAMJ 5/26/05